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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yoshitaka SASAKI et al.

Application No.: 10/067,863

Filed: February 8, 2002

Docket No.: 111926

For: WIRING PATTERN AND METHOD OF MANUFACTURING THE SAME AND  
THIN FILM MAGNETIC HEAD AND METHOD OF MANUFACTURING THE  
SAME

PRELIMINARY AMENDMENT

Director of the U.S. Patent and Trademark Office  
Washington, D. C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Page 24, delete lines 24-26.

Page 24, lines 4-5, delete current paragraph and insert therefor:

Fig. 9 is a cross sectional and plan view, respectively illustrating the known thin film magnetic head;

Page 24, lines 16-17, delete current paragraph and insert therefor:

Figs. 22A and 22B are cross sectional views representing a next manufacturing step;

Page 24, lines 18-20, delete current paragraph and insert therefor:

Figs. 23-31 are cross sectional views showing successive steps of an embodiment of the method of manufacturing a conductive pattern according to the invention; and

Page 24, lines 21-23, delete current paragraph and insert therefor:

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Figs. 32-39 are cross sectional views depicting successive steps of another embodiment of the method of manufacturing a conductive pattern according to the invention.

REMARKS

Claims 1-53 remain pending in this application.

By this Preliminary Amendment, the Brief Description of the Drawings is amended to: 1) only refer to Figure 9, instead of Figures 9A and 9B; 2) refer to Figures 22A and 22B, instead of Figure 22; and 3) delete any reference to Figures 42-46.

Respectfully submitted,



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Attached: Appendix  
Date: December 2, 2002

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APPENDIX

Changes to Specification:

Page 24, lines 24-26 are deleted.

Page 24, lines 4-5:

Fig. 9 is a Figs. 9A and 9B are cross sectional and plan views, respectively illustrating the known thin film magnetic head;

Page 24, lines 16-17:

Figs. 22A and 22B are Fig. 22 is a cross sectional views representing a next manufacturing step;

Page 24, lines 18-20:

Figs. 23-31 are cross sectional views showing successive steps of an embodiment of the method of manufacturing a conductive pattern according to the invention; and

Page 24, lines 21-23:

Figs. 32-39 are cross sectional views depicting successive steps of another embodiment of the method of manufacturing a conductive pattern according to the invention; and,